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Date of Signature and Deposit: February 16, 2004

Attorney of Record

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Richard D. Harris, et al.  
Serial No.: 09/843,545  
Filed: 04/26/2001  
Examiner: Culbert, Roberts P.  
Group Art Unit: 1763  
Docket No.: 01AB021  
Title: *Method for Fabricating an Isolated Microelectromechanical System (MEMS) Device Using an Internal Void*

AMENDMENT AFTER FINAL

Mail Stop AF  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA, 22313-1450

Dear Sir:

In response to the Office Action dated October 15, 2003, please amend the above-identified patent application as follows:

Enter

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3/2/04

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